MAR 2 9 2002 4

Atty. Dkt. No. 039153-0441 (G0406)

CERTIFICATE OF MAILING

Energy, entity that this correspondence is being a though United States Postal Service with

the date below

postage as First Class Mail in an envelope ac Commissioner for Patents, Washington, D.C.

Chris Escavaille

Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Philip A. Fisher et al.

Title:

ENHANCED TRANSISTOR GATE

USING E-BEAM RADIATION

Appl. No.:

10/017,855

Filing

12/14/2001

Date:

Examiner:

To be assigned

Art Unit:

To be determined

March 25, 2002 (Date of Deposit)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. §§ 1.97-98 and in accordance with the duty of disclosure under 37 C.F.R. §1.56, Applicant submits herewith the references listed on the attached Form PTO-1449 to the Examiner such that they may be considered and made of record in the above-identified application. A copy of each reference is enclosed.

Respectfully submitted,

Date

FOLEY & LARDNER

Firstar Center

777 East Wisconsin Avenue

Milwaukee, Wisconsin 53202-5367

Telephone:

(414) 297-5768

Facsimile:

(414) 297-4900

Joseph N. Ziebert

Attorney for Applicant Registration No. 35,421 Form PTO-1449 (MODIFIED) U.S. DEPAR MENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. 39153/441

SERIAL NO.

10/017,855

INFORMATION DISCLOSURE CHATION

APPLICANT

FILING DATE

Philip A. Fisher et al.

MAR 2 9 2002

GROUP ART UNIT

(Use several sheets if necessary)

TEOM...**12/14/2001** ...ER 2000

To be determined

🗞 JUS. PATÉNT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT DATE		NAME	CLASS	SUB- CLASS		
	A1	09/819.342		Shields et al.			03/28/01 03/28/01	
	A2	09/819.343		Gabriel et al.				
	A3	09/819.344		Okoroanyanwu et al.		1	03/28/01	
<u> </u>	A4	09/819.552	1	Gabriel et al.			03/28/01	
	A5	09/819.692		Okoroanyanwu et al			03/28/01	
	A6	09/820.143		Okoroanyanwu et al.			03/28/01	
-	A7	6,107,172	08/22/00	Yang et al	438	585		
	A8	6,103,457	08/15/00	Gabriel	430	318		
	A9	5,965,461	10/12/99	Yang et al	438	717		
	A10	5,003,178	03/26/91	Livesay	250	492.300	!	
		L	FOREIGI	N PATENT DOCUMENTS	 S		<u> </u>	
A AMERICAN TO THE PARTY OF THE	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSL	ATION NO
			!			-		
		OTHER DOCU	MENTS (Inclu	ding Author, Title, Date, F	Pertinent Pages.	Etc.)		
	A11	Livesay, W. R., "La 6, Nov./Dec. 1993.	arge-area electro pp. 2304-2308	on-beam source," Journal of American Vacuum Society	f Vacuum Science	& Technolog	gy B, Vol. 1	1, No.
	A12	Yank, J. J. et al, "E (BEOL) Integration Research Society	lectron Beam P ," Materials Res	Processing for Spin-on Polyn search Society Symposium F	ners and its Applic Proceedings, Vol.	cations to Bac 511, 1998, p	ck-End-of-L p. 49-55, N	ine laterial:
	A13	Ross et al "Plasma Optical Instrument Engineering	a Etch Characte ation Engineers	eristics of Electron Beam Pro , Vol. 2438, 1995, pp. 803-8	ocessed Photores 16, SPIE- The Int	ist,." The Soc ernational So	iety of Pho ciety for Op	to- otical
	A14	: Elektronenauellen	Eindimensional	otometrische Mesungen der er Fall in Luft", Zeitschrift für chung; full English Translatio	r Naturforschung;	Vol. 12a, 195	gsfeld von 57, pp. 89-9	95.

EXAMINER

DATE CONSIDERED

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any copy of this form with next communication to applicant.